ABSTRACT OF THE DISCLOSURE

A method for placement of a object such as a substrate or a mask on a table, said method including:

- a first placement step in which the object is placed on a first position on the table;
- a measuring step in which a displacement between the first position of the object and the required position of the object is determined;
 - a removing step in which the object is released and removed from the table;
- a moving step in which the object and the table are moved relatively to each other by substantially the said displacement, in a direction substantially parallel to the surface of the table; and
- a second placement step in which the object is placed at the required position on the table.

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ABSTRACT:

"Object positioning method for a lithographic projection apparatus"

A method for placement of a object 1 such as a substrate or a mask on a table 5, said method comprises the following steps:

a first placement step in which the object 1 is placed on a first position on the table 5;

a measuring step in which a displacement between the first position of the object 1 and the required position of the object 1 is determined;

a removing step in which the object 1 is released and removed from the table 5; a moving step in which the object 1 and the table 5 are moved relatively to each other by substantially the said displacement, in a direction substantially parallel to the surface 13 of the table 5; and

a second placement step in which the object 1 is placed at the required position on the table 5.

Fig. 5